

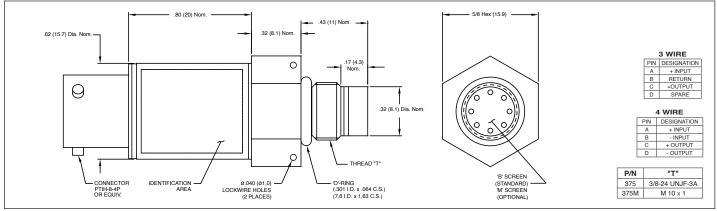
5 VDC OUTPUT PRESSURE TRANSDUCER ETM-375 (M) CO SERIES

- 5 VDC Output
- Hybrid Microelectronic Regulator-Amplifier
- Silicon on Silicon Integrated Sensor VIS®
- · Flush Diaphragm
- All Welded Construction
- · Secondary Containment On Absolute And Sealed Gage Units
- 3/8-24 UNJF or M10 X 1 Thread
- 4 Wire (ETM-375) 3 Wire (ETM-300-375)
- Intrinsically Safe Applications Available (i.e. IS-ETM-375)

ETM-375(M) CO Series transducers are miniature, threaded flush diaphragm instruments. They utilize a flush metal diaphragm as a force collector. Force is transferred to a solid state piezoresistive sensing element via a thin intervening film of non-compressible silicone oil. This sensing sub-assembly is protected from mechanical



damage by a solid screen which has been shown to have minimal influence of the frequency response of the sensor. For applications where a true flush diaphragm is needed, Kulite will supply these transducers without the screen. Incorporation of a Kulite proprietary electronics module within the main body of this product allows for operation from an unregulated power supply of 12 \pm 4 VDC or 28 \pm 4 VDC. Standard output is a stable, low noise 0 to 5 VDC signal.



INPUT	Pressure Range	17 250	35 500	70 1000	170 2500	350 5000	700 10000	1400 BAR 20000 PSI
	Operational Mode	Absolute, Sealed Gage						
	Over Pressure	2 Times Rated Pressure to 1000 PSI (70 BAR) 1.5 Times Rated Pressure Above 1000 PSI to a Max. of 25000 PSI (1724 BAR)						
	Burst Pressure	3 Times Rated Pressure to a Max. of 25000 PSI (1724 BAR)						
	Pressure Media	Any Liquid or Gas Compatible With 15-5 PH or 316 Stainless Steel						
	Maximum Electrical Current	25 mA						
	Rated Electrical Excitation	8 - 16 VDC			13 - 32 VDC			
ENVIRONMENTAL OUTPUT	Full Scale Reading		5 VDC ± 150 mV		5 VDC ± 150 mV or 10 VDC ± 300 mV			
	Output Impedance	200 Ohms (Max.)						
	Bandwidth (-3dB)	DC to 5 KHz						
	Residual Unbalance		0 to 100 mV	(ETM-375)	20	200 mV ± 50 mV (ETM-300-375)		
	Combined Non-Linearity, Hysteresis and Repeatability	± 0.1% FSO BFSL (Typ.), ± 0.5% FSO (Max.)						
	Resolution	Infinitesimal						
	Natural Frequency of Sensor Without Screen (KHz) (Typ.)	Greater Than 400 KHz						
	Acceleration Sensitivity % FS/g Perpendicular	2.2x10 ⁻⁴	1.1x10 ⁻⁴	6.2x10 ⁻⁵	2.6x10 ⁻⁵	1.5x10⁻⁵	1.3x10 ⁻⁵	8.0x10 ⁻⁶
	Insulation Resistance	100 Megohm Min. @ 50 VDC						
	Operating Temperature Range	-65°F to +250°F (-55°C to +120°C)						
	Compensated Temperature Range	0°F to +212°F (-18°C to +100°C) Other Ranges Quoted on Request						
	Thermal Zero Shift	± 1% FS/100° F (Typ.)						
	Thermal Sensitivity Shift	± 1% /100° F (Typ.)						
	Linear Vibration	100g Peak, Sine up to 5000 Hz						
	Mechanical Shock	100g half Sine Wave 11 msec. Duration						
PHYSICAL	Electrical Connection	PTIH-8-4P or Equivalent (Mating Connector Available Upon Request)						
	Weight	24.5 Grams (Nom.)						
	Pressure Sensing Principle	Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon						
4	Mounting Torque	80 Inch-Pounds (Max.)						

Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (C) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2020 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.